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JRW

Docket No.: M4065.0353/P353-A  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Gurtej Sandhu et al.

Application No.: 09/982,954

Confirmation No.: 8784

Filed: October 22, 2001

Art Unit: 1763

For: ATOMIC LAYER DOPING APPARATUS  
AND METHOD

Examiner: K. A. Moore

**RESPONSE AFTER FINAL ACTION UNDER 37 C.F.R. § 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated February 7, 2007, finally rejecting claims 1, 7-10 and 46-52, please reconsider the above-identified U.S. patent application in light of the following:

**Listing of the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.